Ref	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	4047	electrode same photovoltaic	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/03 14:19
L2	2581	electrode near10 photovoltaic	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/03 14:19
L3	0	electrode near10 photovoltaic near10 germanium	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/03 14:19
L4	2	electrode near10 photovoltaic near10 sige	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/03 16:16
L5	523	(recrystal\$6 or solid near2 grow\$4) near15 (silicon or si) near5 amorphous same laser	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/03 16:18
L6	523	(recrystal\$6 or solid near2 grow\$4) near15 (silicon or si) near5 amorphous same laser	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/03 16:37
L7	58	(recrystal\$6 or solid near2 grow\$4) near15 (silicon or si) near5 amorphous near10 (laser and heat\$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/03 16:39
L8	0	(recrystal\$6 or solid near2 grow\$4) near15 (silicon or si) near5 amorphous near10 (laser and heat\$6) same (germanium ge or sige)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/03 16:45
L9	7192	(shunpei near2 yamazaki or toru near2 mitsuki or kenji near2 kasahara or tamae near2 takano or takeshi near2 shichi or chiho near2 kokubo).in. or semiconductor near2 energy near2 laboratory.as.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/03 16:48

L10	470	9 and laser same amorphous same polycrystal\$6	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/03 16:49
L11	22	9 and laser same amorphous same polycrystal\$6 same (silicon near2 germanium or sige)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/03 16:52
L12	83	laser same amorphous same polycrystal\$6 same (silicon near2 germanium or sige)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/03 16:52
L13	24	(anneal\$4 or heat near2 treat\$5) near15 amorphous near15 polycrystal\$6 near15 (silicon near2 germanium or sige)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/03 16:55